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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Saka et al.

Serial No. 10/029,080

Filed: December 21, 2001

Title: In-Situ Method and Apparatus for End
Point Detection in Chemical Mechanical
Polishing

Examiner: To be assigned

Art Unit: To be assigned

INFORMATION DISCLOSURE
STATEMENT TRANSMITTAL

Date: March 12, 2002

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MAR 22 2002
TECHNOLOGY CENTER 2300

CERTIFICATE OF MAIL (37 CFR 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231 on March 12, 2002.

Signed:

Kari Bateman

Box: DD

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmitted herewith is:

- [x] a Information Disclosure Statement;
- [x] PTO 08A & 08B;
- [x] Copies of forty-seven (47) references listed on the PTO 08A and 08B form;
- [x] This Information Disclosure Statement is filed under 37 C.F.R. 1.97(b)(3);
Accordingly, no fee is required.
- [x] The Commissioner is hereby authorized to charge any underpayment of the fees to
Deposit Account No. 06-1300 (A-69174-1/MSS);
- [x] Self-addressed return postcard.

Respectfully submitted,

FLEHR HOHBACH TEST
ALBRITTON & HERBERT LLP

Maria S. Swiatek, Reg. No. 37,244

Four Embarcadero Center, Suite 3400
San Francisco, CA 94111-4187
Telephone (650) 494-8700
Facsimile (650) 494-8771

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